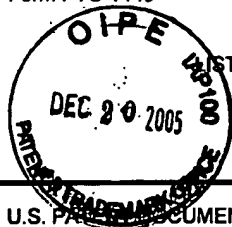


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Sheet 1 of 1

Form PTO-1449

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H. Montgomery ManningFILING DATE
Sept. 4, 2003 [RCE filed herewith]GROUP
2812

U.S. PATENT DOCUMENTS

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AG	AA	6,617,222	09/03	Coursey			
	AB	2001/0012223	08/01	Kohyama			
	AC	2002/0030221	03/02	Sandhu et al.			
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	AI						
	AL						

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							Yes	No
AG	AK	2004/ 040252	12/04	PCT Search Report				
	AL							

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AG	AM	Kim, D. et al., "A Mechanically Enhanced Storage Node for Virtually Unlimited Height (MESH) Capacitor Aiming at Sub 70nm DRAMs", IEEE Jan. 2004, pp. 3.4.1 – 3.4.4.
	AN	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.